

Attorney Docket No. 450101-02950

New Patent Application filed **September 24, 2001**, entitled:

**INFORMATION PROCESSING APPARATUS AND PROCESSING METHOD, AND  
PROGRAM STORAGE MEDIUM**

corresponding to PCT Application No. PCT/JP01/00420

filed January 23, 2001

Express Mail No.: EL819056119US

Date of Deposit: September 24, 2001

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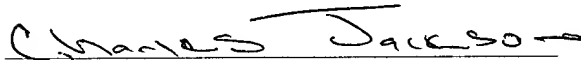
Applicant(s) : Fukuda, et al.  
Int'l Appln. No. : PCT/JP01/00420  
Int'l Filing Date : January 23, 2001  
Title of Invention : INFORMATION PROCESSING APPARATUS  
AND PROCESSING METHOD, AND PROGRAM  
STORAGE MEDIUM


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**INFORMATION DISCLOSURE STATEMENT**

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Dear Sir:

Enclosed are copies of the publications which were cited in the International Search Report of International Application No. PCT/JP01/00420. Also enclosed is a copy of Form PTO-1449 and the International Search Report.

09/937463

REMARKS


Entry of this Information Disclosure Statement and an early examination on the merits are respectfully solicited.

Please charge any additional fees to Deposit Account No. 50-0320.

Respectfully submitted,

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Enclosures

Based on Form PTO-1449 (3/90)				ATTY. DOCKET NO.  <b>450101-02950</b>		SERIAL NO.  <b>09/937463</b>	
LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT  <p style="text-align: center;"><b>Fukuda, et al.</b></p>			
				FILING DATE		GROUP	

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AK	11-146333	05/28/99	Japan				
	AL	10-200814	07/31/98	Japan				
	AM	7-46462	02/14/95	Japan				
	AN	10-248048	09/14/98	Japan				
	AO	9-146918	06/06/97	Japan				
	AP	9-270992	10/14/97	Japan				
	AQ	2000-50204	02/18/00	Japan				
	AR	2000-149045	05/30/00	Japan				

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)			
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